

MNC 2019



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ABSTRACT DEADLINE

June 24, 2019

October 28-31, 2019

International Conference Center Hiroshima, Hiroshima, Japan

CONFERENCE SCOPE

- 1: Lithography and Related Technologies and Metrology
 - 1-1: Photolithography and Patterning
 - 1-2: Electron and Ion Beam Technologies
 - 1-3: Resist and Directed Self-Assembly
- 2: Nanotechnology
 - 2-1: Nanocarbons
 - 2-2: Nanodevices
 - 2-3: Nanofabrication
 - 2-4: Inorganic Nanomaterials
 - 2-5: Organic Nanomaterials
 - 2-6: NanoTool
- 3: Nanoimprint, Hybrid-NIL, Biomimetics, and Functional Surfaces
- 4: BioMEMS, Lab on a Chip, and Nanobiotechnology
- 5: Microsystem Technology and MEMS

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